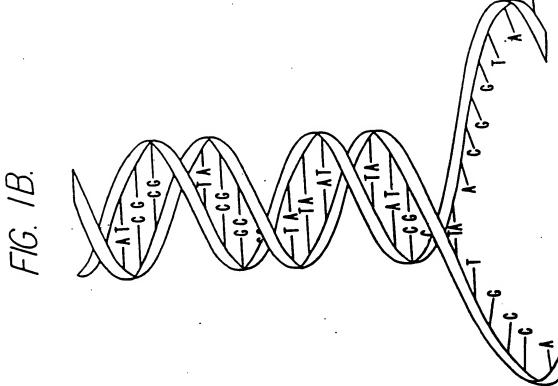
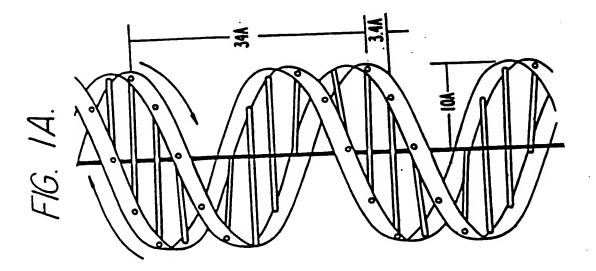
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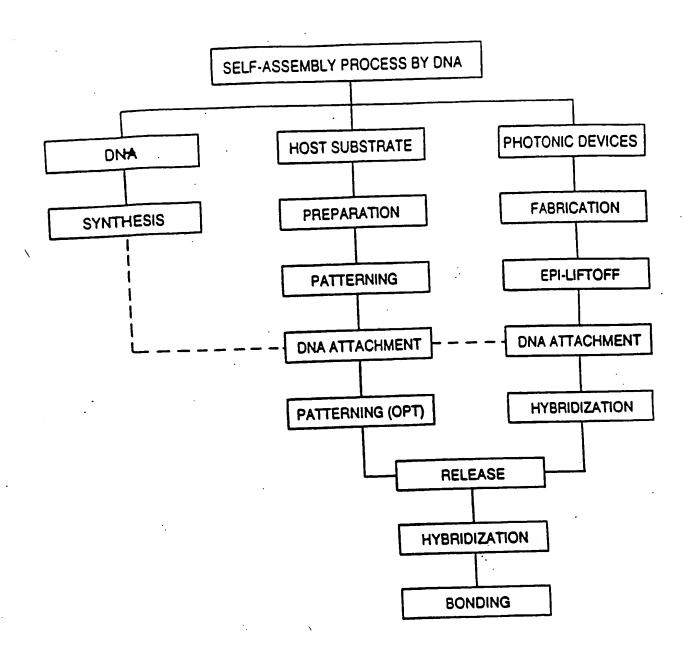
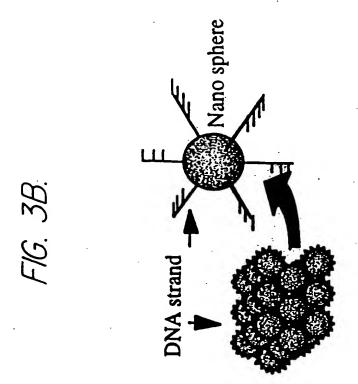
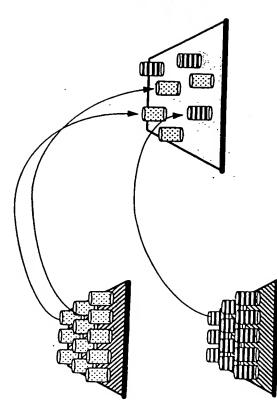


FIG. 2.

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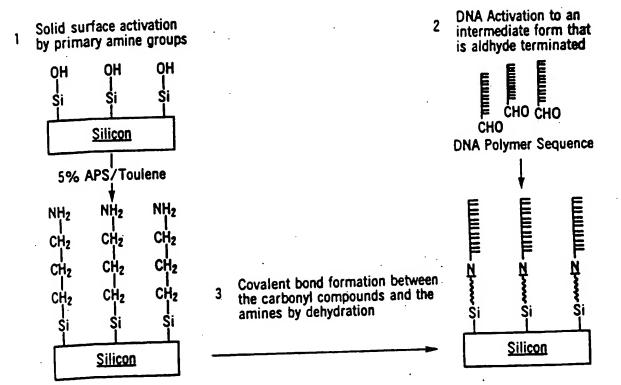
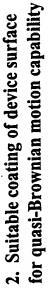


FIG. 4.

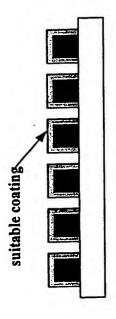
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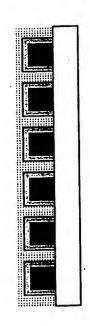
5. Polyimide recess 1. Standard micro/nano device fab. with sacrificial layer for liftoff



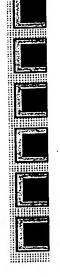
6. Metalization

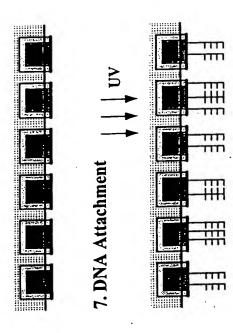


3. Support with polyimide or black wax

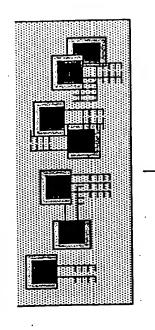


4. Epi-liftoff





8. Release



ybridization with complement

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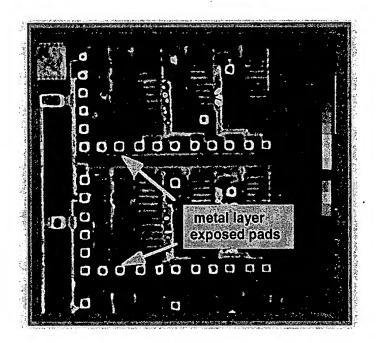


Fig. 6

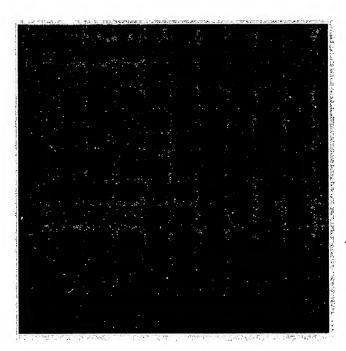


Fig. 7

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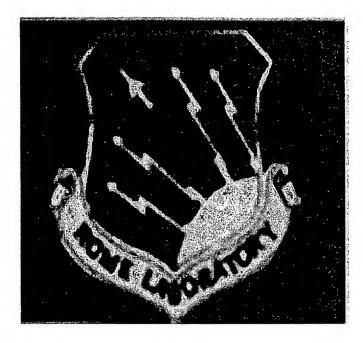


Fig. 8A

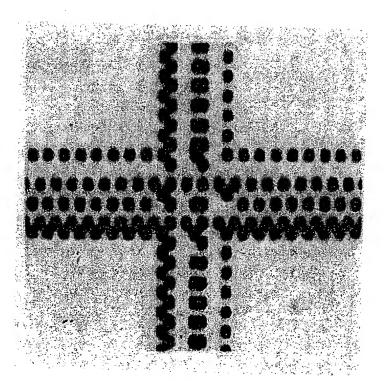


Fig. 8B

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FIG. 9

PROCESS FOR PREPARING FOUR ID DNA WRITE MATERIAL

THE DNA WITH SEQUENCE (A) IDENTITY IS BOUND COVALENTLY TO THE ENTIRE SURFACE

DNA SEQUENCE (A)

COVALENT

ATTACHMENT TO

SURFACES

LOCATION 1

IDENTITY (A)

LOCATION 4

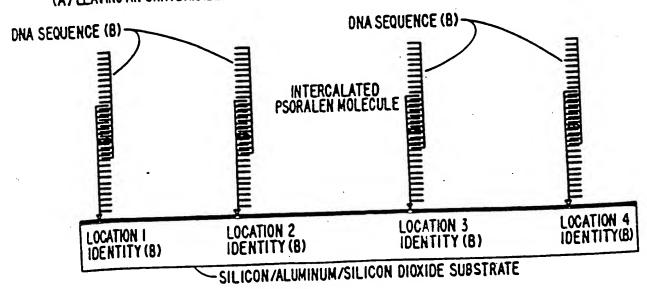
IDENTITY (A)

FIG. 10

SILICON/ALUMINUM/SILICON DIOXIDE SUBSTRATE

PROCESS FOR PREPARING FOUR D DNA WRITE MATERIAL

DNA SEQUENCE (B) FUNCTIONALIZED WITH A PSORALEN MOLECULE IS HYBRIDIZED TO SEQUENCE (A) LEAVING AN UNHYBRIDIZED OVERHANG SEQUENCE FOR SUBSEQUENT HYBRIDIZATION



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LOCATION #1 IS MASKED FROM UV EXPOSURE WHILE LOCATIONS 2,3 &4 ARE EXPOSED ALLOWING THE PSORALEN MOLECULES TO COVALENTLY CROSS-LINK THE (A) AND (B) DNA SEQUENCE.

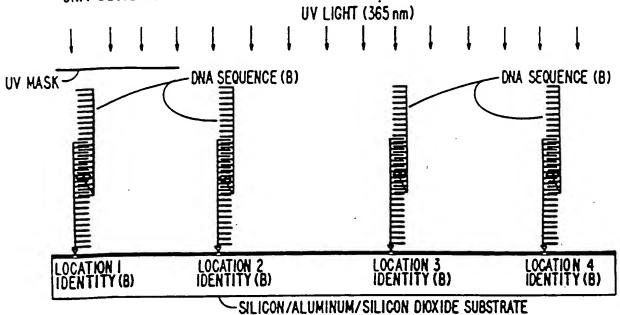
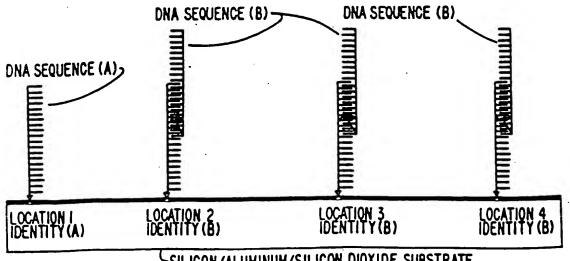


FIG. 12

PROCESS FOR PREPARING FOUR ID DNA WRITE MATERIAL

DEHYBRIDIZATION IS CARRIED OUT TO REMOVE THE NON-CROSSLINKED SEQUENCE (B) FROM THE IST LOCATION, WHICH NOW HAS A PERMANENT (A) SEQUENCE IDENTITY. DNA SEQUENCE (B) IS NOW COVALENTLY COUPLED TO LOCATIONS 2, 3 AND 4



SILICON/ALUMINUM/SILICON DIOXIDE SUBSTRATE

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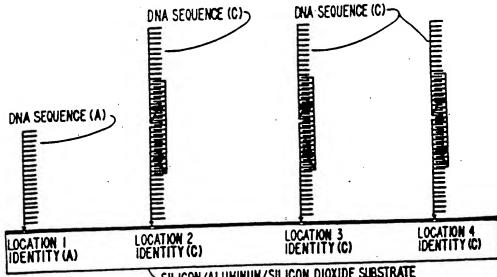
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FIG. 13.

PROCESS FOR PREPARING FOUR ID DNA WRITE MATERIAL

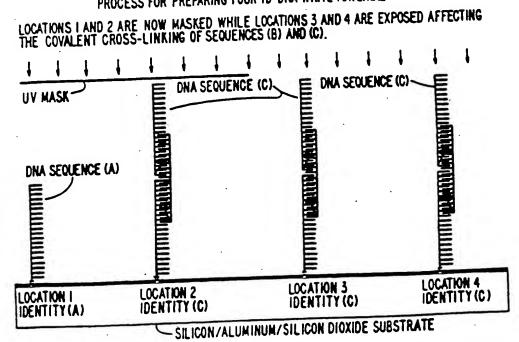
A PSORALEN FUCTIONALIZED DNA SEQUENCE (C) IS NOW HYBRIDIZED TO SEQUENCE (B), AND THE PROCESS IS REPEATED.



SILICON/ALUMINUM/SILICON DIOXIDE SUBSTRATE

FIG. 14.

PROCESS FOR PREPARING FOUR ID DNA WRITE MATERIAL



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FIG. 15

PROCESS FOR PREPARING FOUR ID DNA WRITE MATERIAL

DEHYBRIDIZATION IS CARRIED OUT TO REMOVE SEQUENCE (C) FROM LOCATION 2. A PERMANENT (B) DNA SEQUENCE IDENTITY IS NOW PRESENT AT LOCATION 2

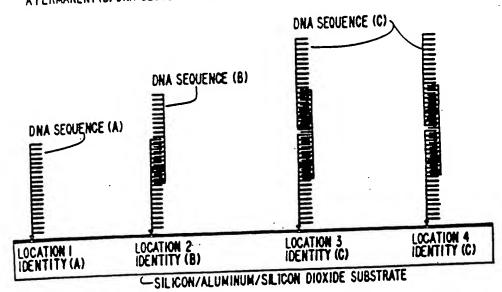
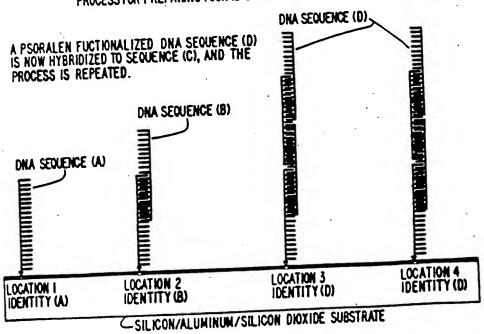


FIG. 16
PROCESS FOR PREPARING FOUR ID DNA WRITE MATERIAL

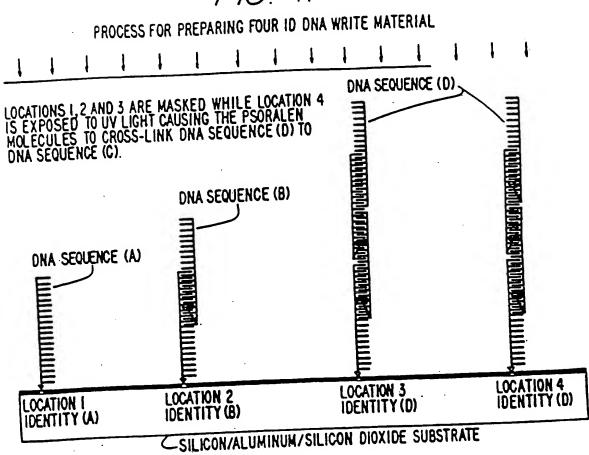


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FIG. 17



INVENTOR(S): U.S. Serial No.:

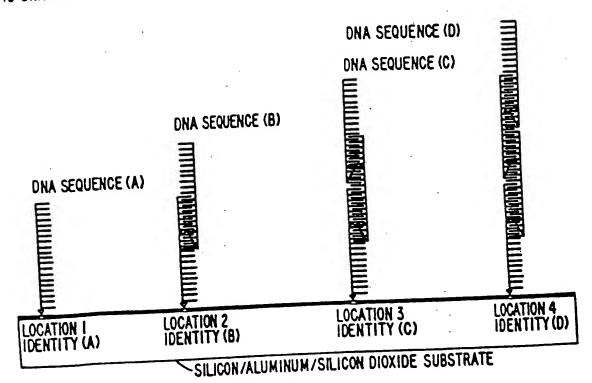
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FIG. 18

PROCESS FOR PREPARING FOUR ID DNA WRITE MATERIAL

DEHYBRIDIZATION IS CARRIED OUT TO REMOVE DNA SEQUENCE (D) FROM LOCATION 3. A PERMANENT (C) IDENTITY IS PRESENT AT LOCATION 3 AND A PERMANENT (D) IDENTITY IS PRESENT AT LOCATION 4. THIS COMPLETES THE PROCESS FOR PREPARING A FOUR ID DNA WRITE MATERIAL.



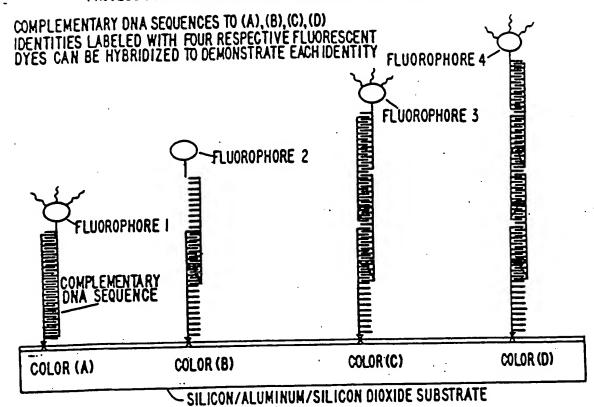
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FIG. 19

PROCESS FOR PREPARING FOUR ID DNA WRITE MATERIAL



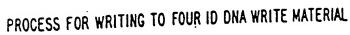
INVENTOR(S): U.S. Serial No.: Heller

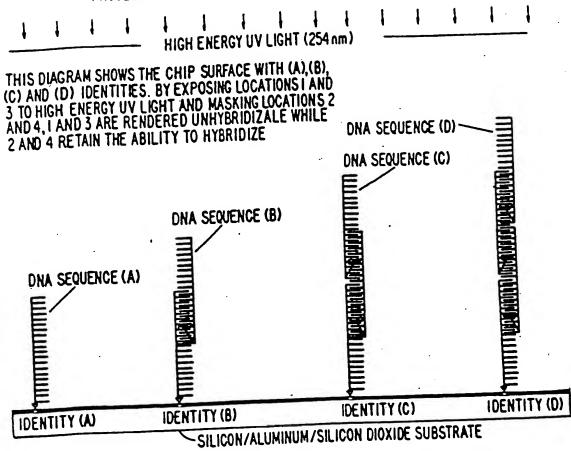
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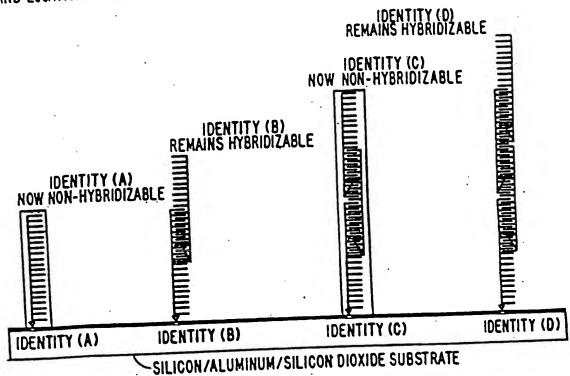
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FIG. 21

PROCESS FOR WRITING TO FOUR ID DNA WRITE MATERIAL

SELECTIVE UV EXPOSURE LEAVES LOCATIONS I AND 3 UNHYBRIDIZABLE AND LOCATIONS 2 AND 4 RETAIN THE ABILITY TO HYBRIDIZE



INVENTOR(S): U.S. Serial No.:

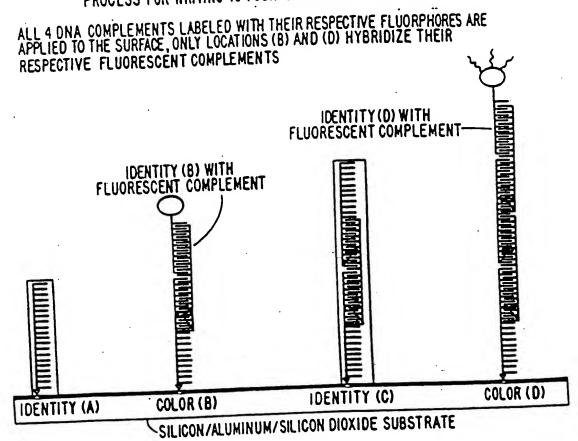
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FIG. 22.

PROCESS FOR WRITING TO FOUR ID DNA WRITE MATERIAL



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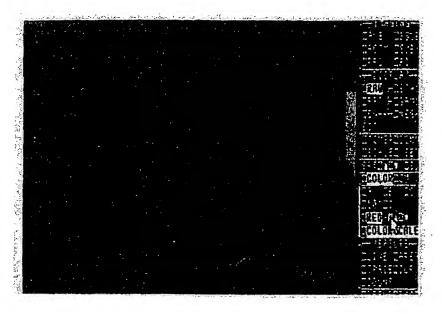


Fig. 23A

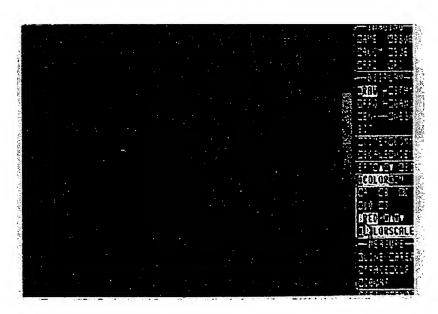


Fig. 23B

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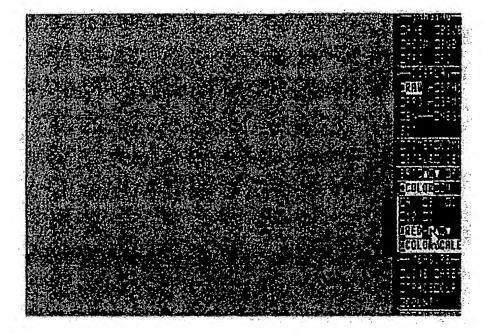


Fig. 24A

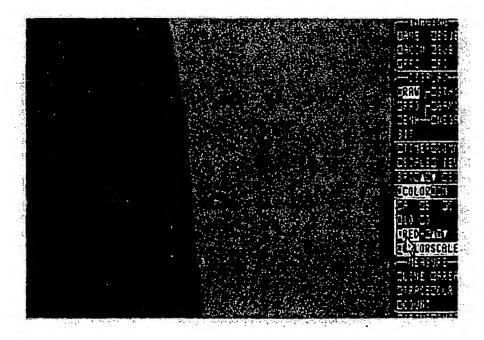


Fig. 24B

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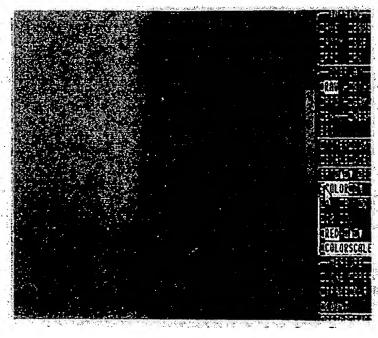


Fig. 25A

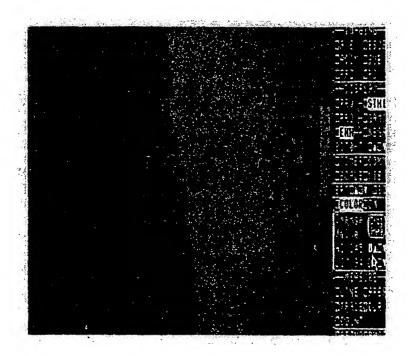


Fig. 25B

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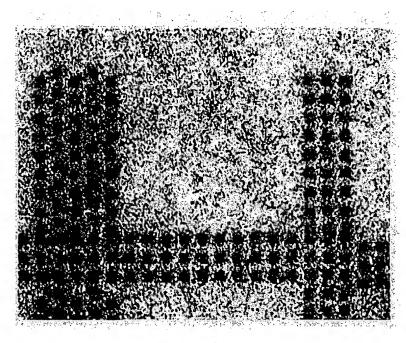


Fig. 26A

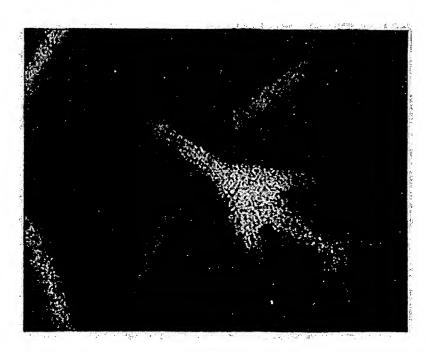


Fig. 26B

and Electronic Ap INVENTOR(S):

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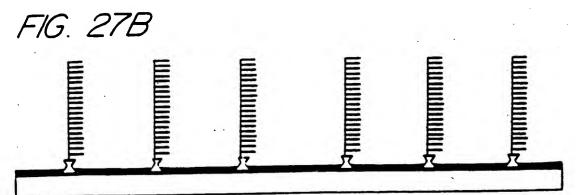
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FIG. 27A

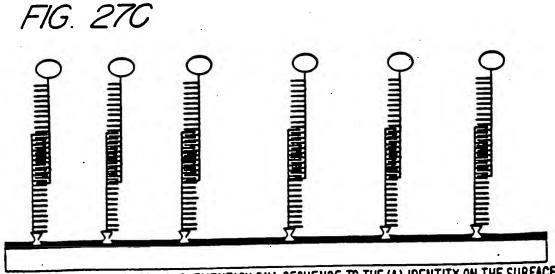
APS SUBSTRATE LAYER



CHIP SURFACE IS FUNCTIONALIZED ONLY WITH APS

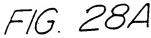


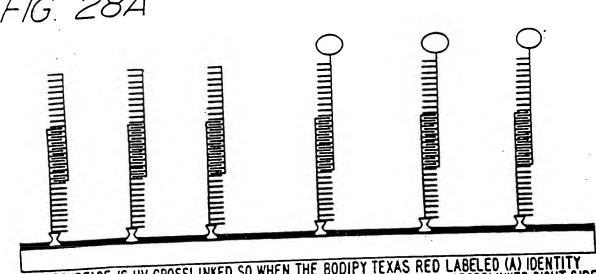
ORIGINAL CAPTURE DNA SEQUENCE A, WHICH IS NOT FLUORESCENTLY LABELED, IS COVALENTLY ATTACHED TO THE APS LAYER ON THE CHIP SURFACE



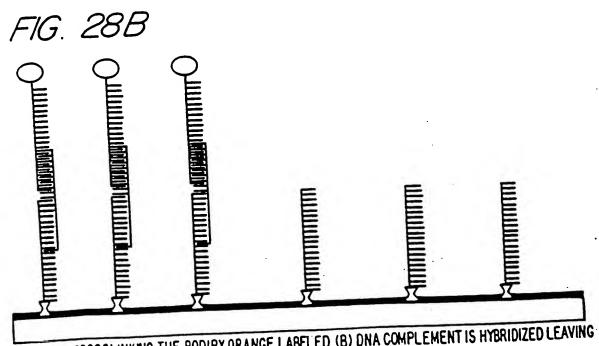
FLUORESCENTLY LABELED COMPLEMENTARY DNA SEQUENCE TO THE (A) IDENTITY ON THE SURFACE IS HYBRIDIZED TO THE ENTIRE CHIP LEAVING THE ENTIRE SURFACE BRIGHT

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1/2 OF SURFACE IS UV CROSSLINKED SO WHEN THE BODIPY TEXAS RED LABELED (A) IDENTITY COMPLEMENT IS HYBRIDIZED ACROSS THE ENTIRE CHIP ONLY THE NON-CROSSLINKED RIGHT SIDE OF THE CHIP ATTAINS COLOR

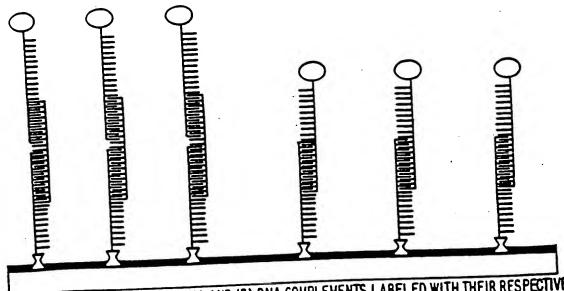


AFTER UV CROSSLINKING THE BODIPY ORANGE LABELED (B) DNA COMPLEMENT IS HYBRIDIZED LEAVING ONLY THE (B) IDENTITY LEFT SIDE OF THE CHIP BRIGHT

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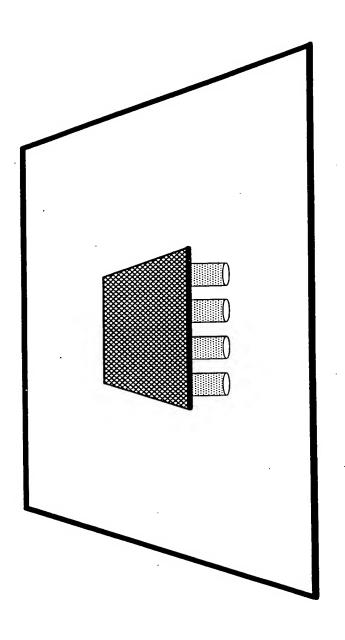
FIG. 28C



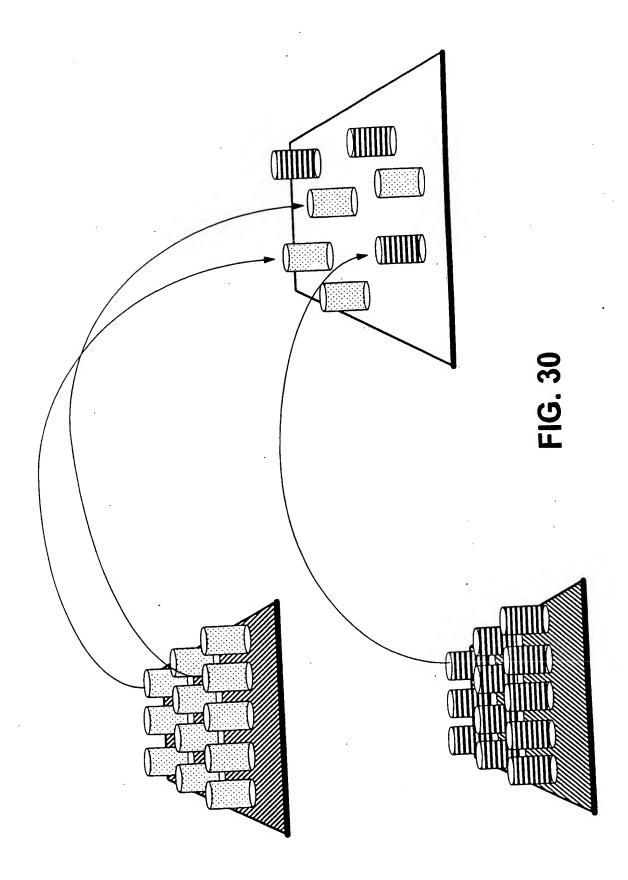
AFTER UV CROSSLINKING BOTH (A) AND (B) DNA COMPLEMENTS LABELED WITH THEIR RESPECTIVE FLUOROPHORES ARE HYBRIDIZED TO THE SURFACE, THE LEFT SIDE ATTAINING THE BODIPY ORANGE AND THE RIGHT ATTAINING THE BODIPY TEXAS RED COLOR

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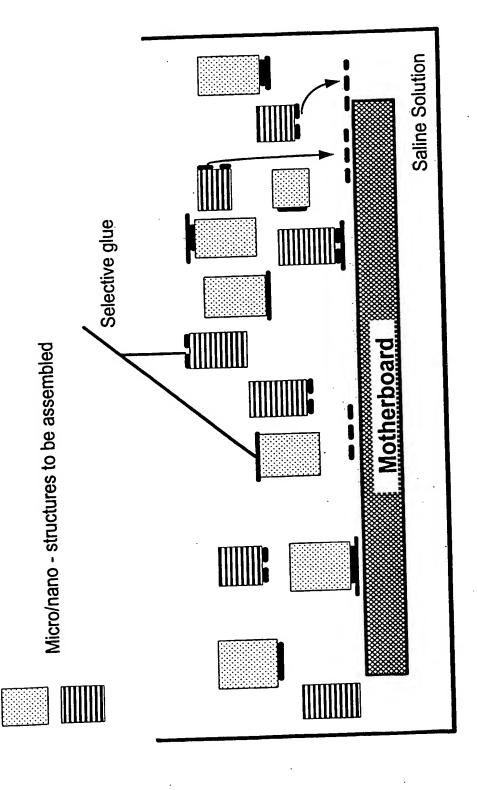


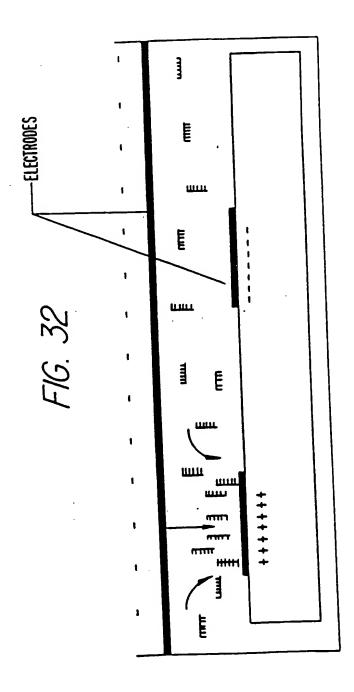
FIG. 31

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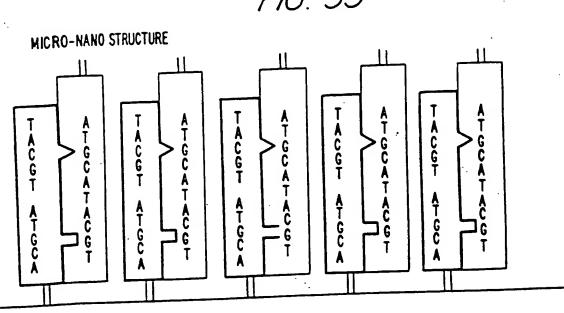
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SILICON SUBSTRATE

NANO STRUCTURE

ACTIVE METAL LAYER
DNA BOND

NANOSCALE METAL BUMP

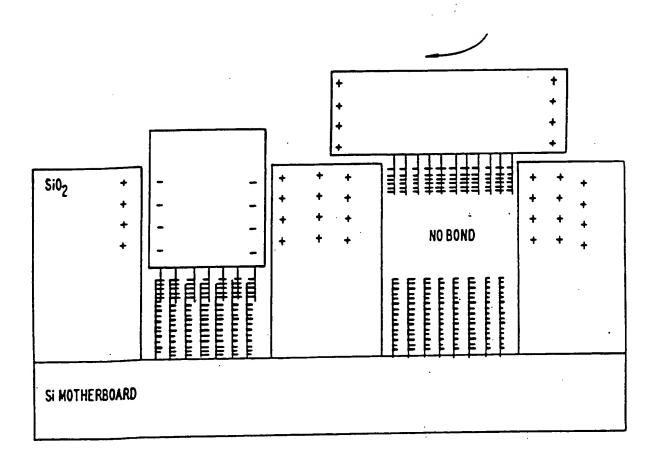
Si MOTHERBOARD

Si MOTHERBOARD

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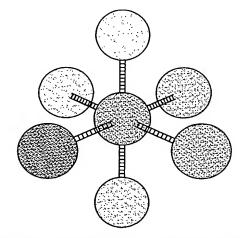
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FIG. 35

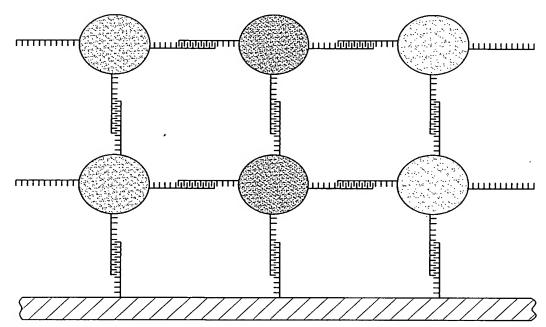


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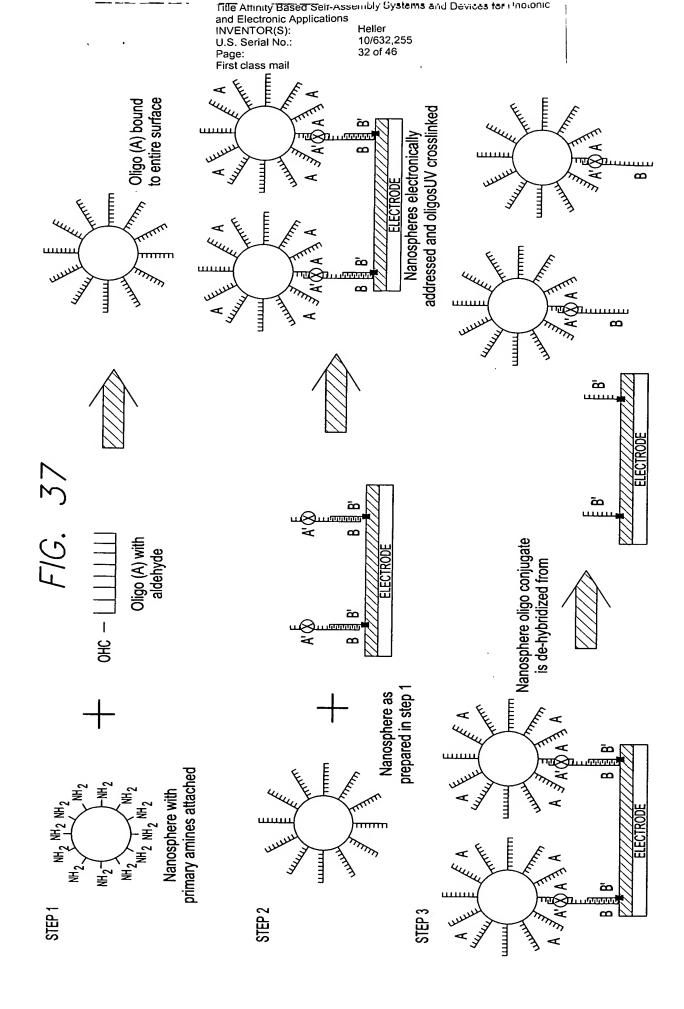


NANOSPHERES ARRANGED IN OCTAHEDRON USING 3D DNA NANOCONSTRUCTION TECHNIQUES

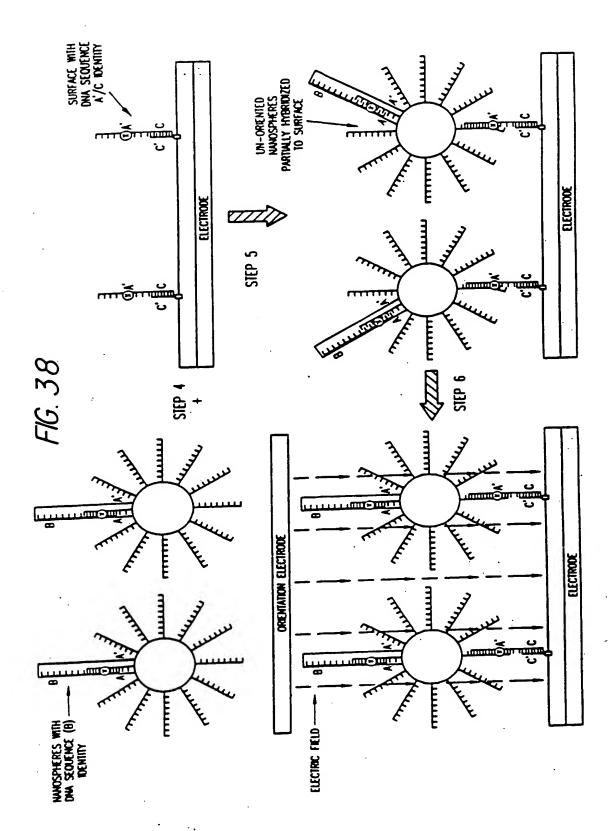


NANOSPHERES ARRANGED INTO LATTICE STRUCTURE AND BOUND TO SURFACE TO CREATE A 3D DEVICE

FIG. 36



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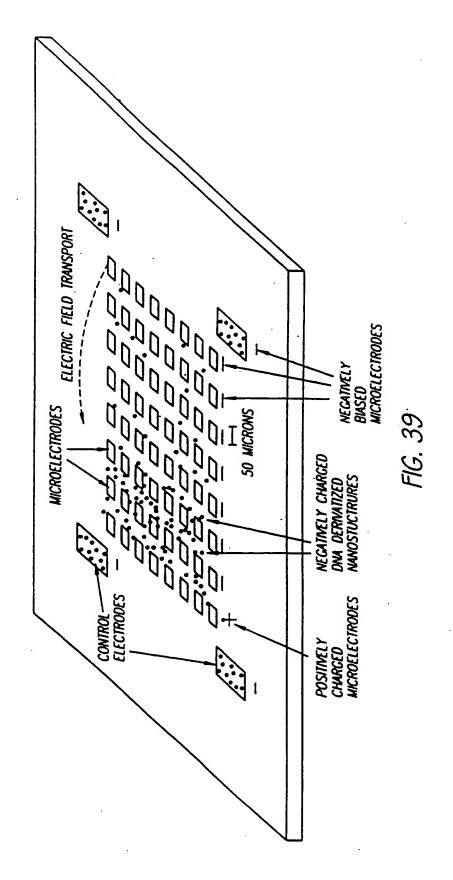


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Title Affinity Based Self-Assembly Systems and Devices for Photonic and Electronic Applications
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TYPE 1 NANOSTRUCTURES ACCUMULATE ON THE POSITVELY BIASED MICRLOCATION

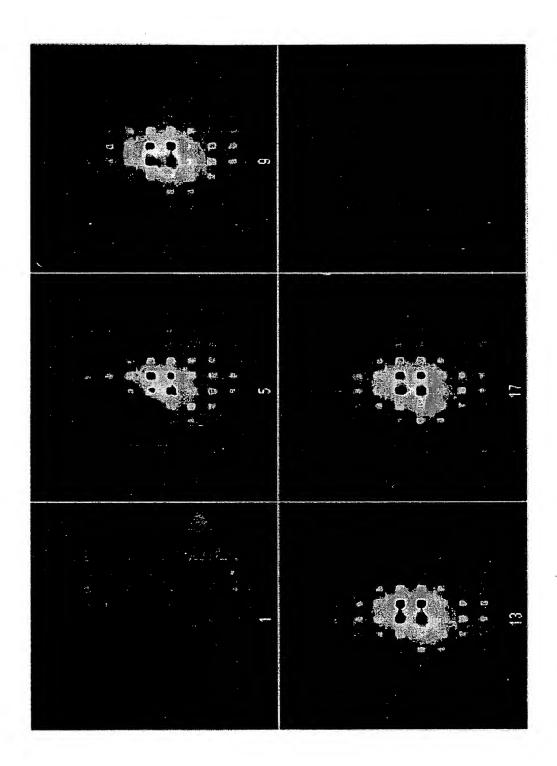
MOVE TOWARD POSITIVELY BIASED MICROLOCATION

- TYPE 1 NANOSTRUCTURES

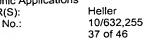
NEGATIVELY CHARGED TYPE I NANOSTRUCTURES

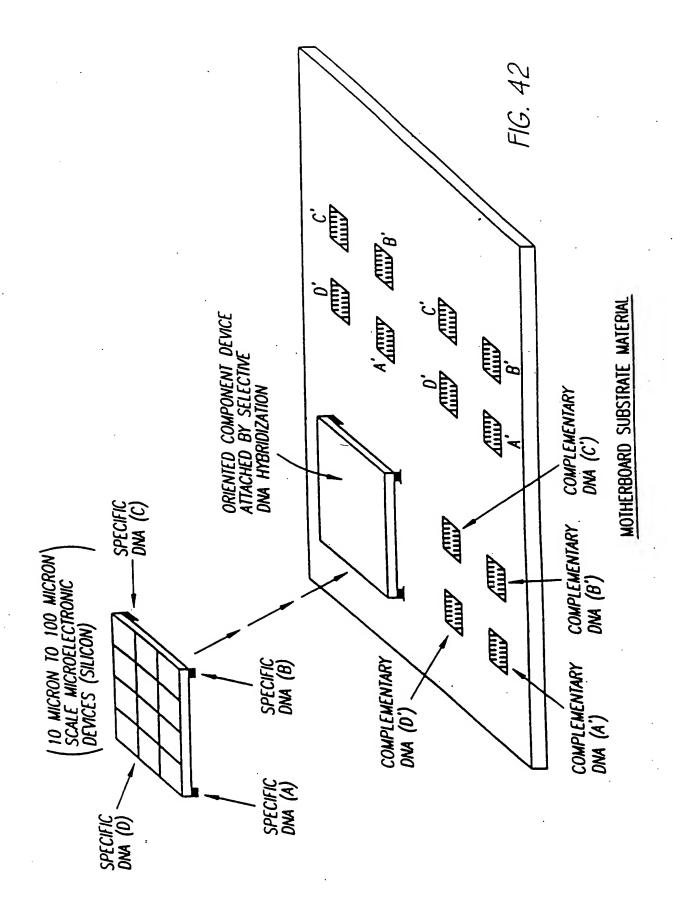
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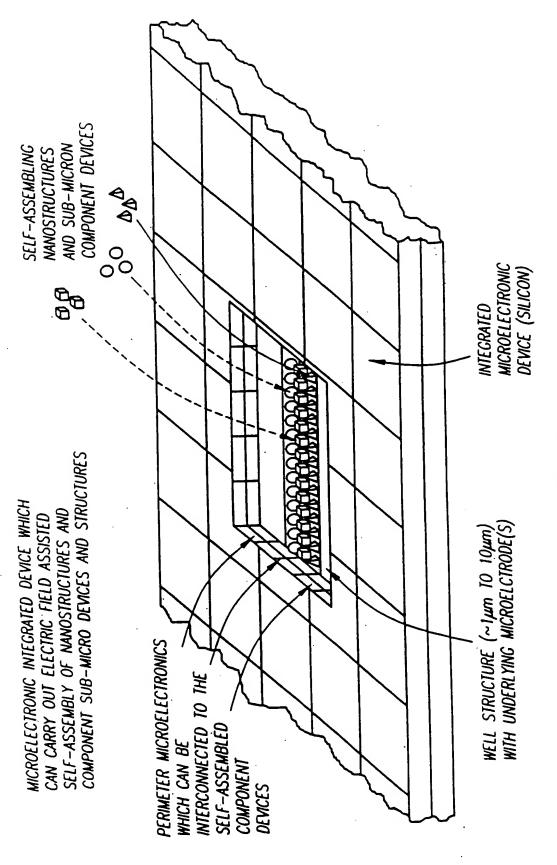


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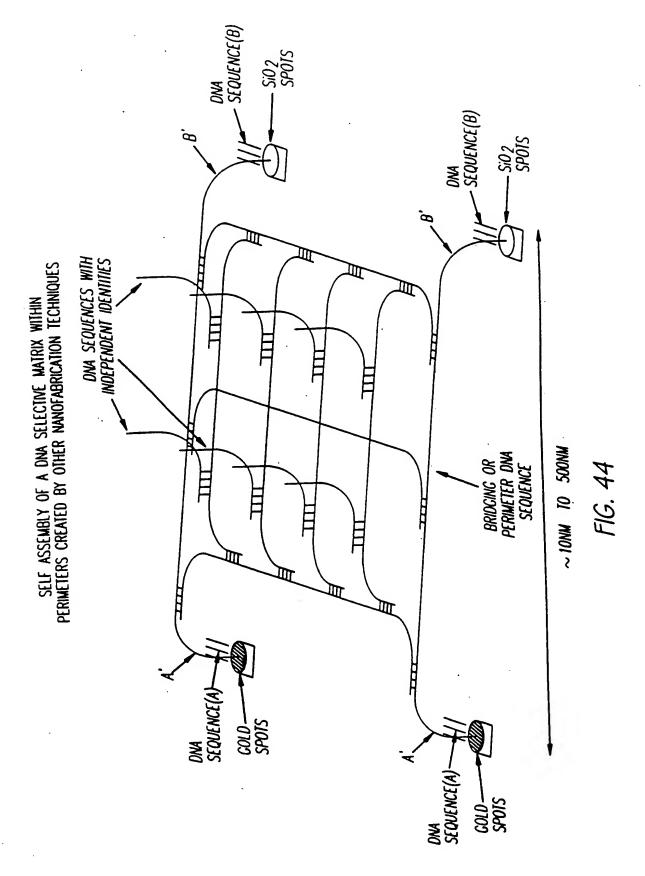


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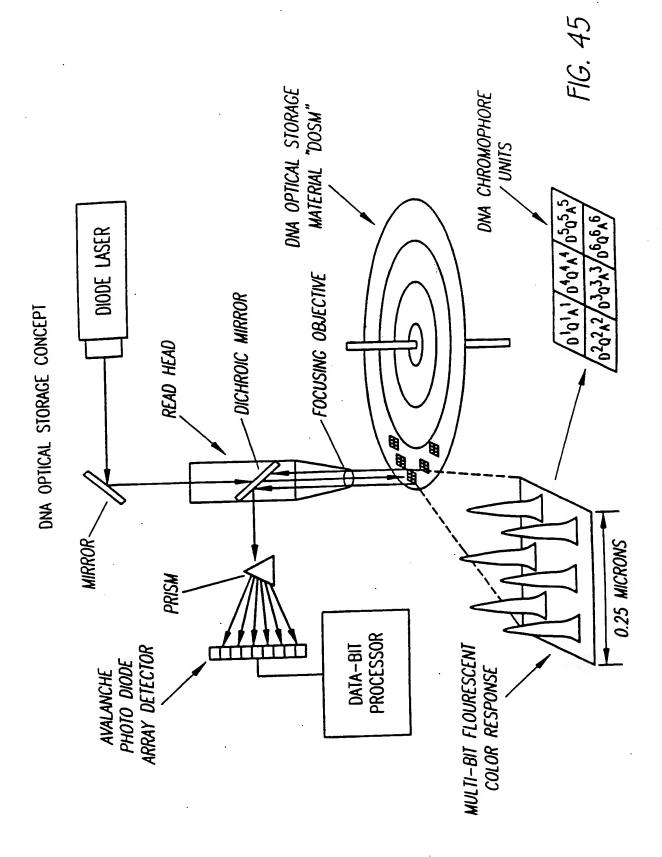
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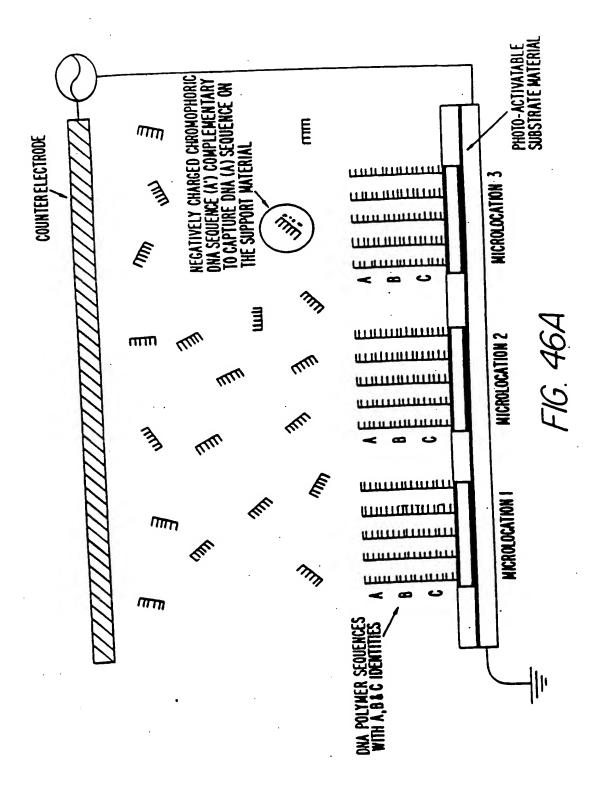


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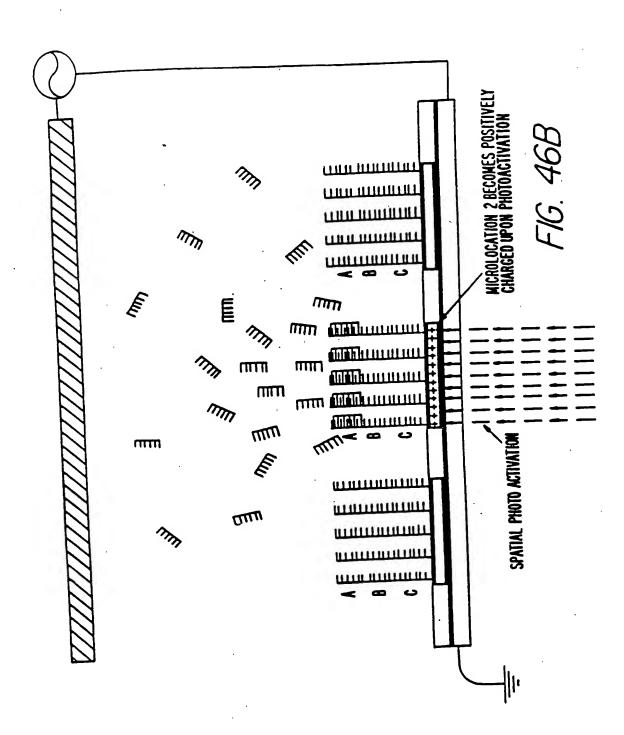
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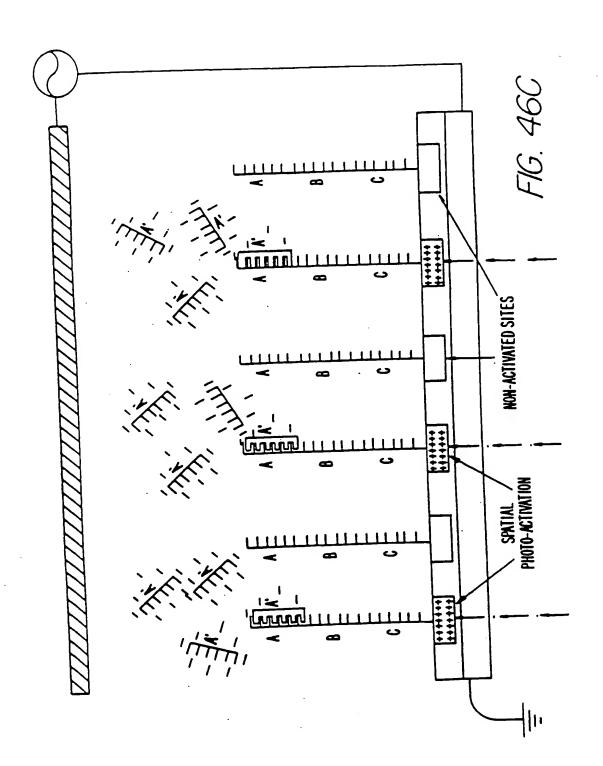


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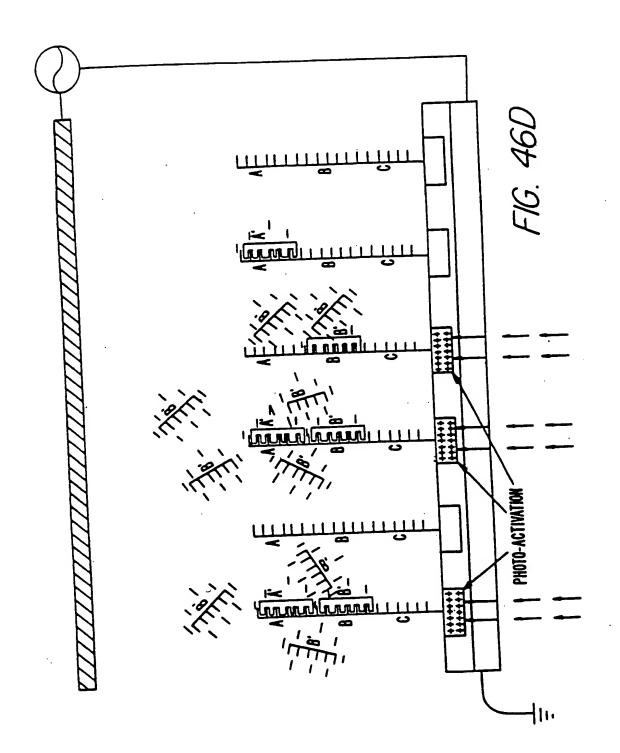
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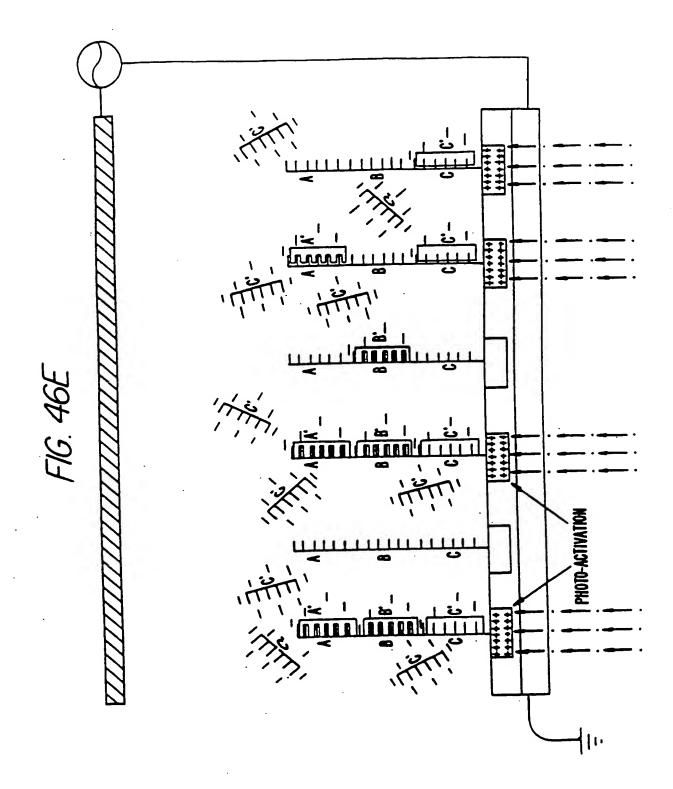
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SPATIAL LIGHT ADRESSING PROCESS COMPLETE

